



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Daisuke KOMADA et al.**

Group Art Unit: 1756

Serial No.: 10/058,426

Examiner: **Nicole M. Barreca**

Filed: **January 30, 2002**

Confirmation No.: 4298

For: **METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE
HAVING SILICON CARBIDE FILM**

Attorney Docket Number: 020060

Customer Number: 38834

INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 C.F.R. §1.97(b)(4)

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

December 21, 2004

Sir:

Applicants direct the attention of the Patent and Trademark Office to the documents listed on the attached Form PTO-1449. A copy of each non-U.S. document is attached.

The document is cited in the Notification of the First Office Action, which dated November 5, 2004, of the corresponding Chinese application in the present application. A copy of the Notification of the First Office Action and its English translation are also attached.

No fee or certification required in connection with this Information Disclosure Statement, because it is being submitted prior to the issuance of a first official action on the merits following the Request for Continued Examination (RCE) in the above-identified patent application.

The above information is presented so that the Patent and Trademark Office can, in the first instance, determine any materiality thereof to the claimed invention. See 37 CFR 1.104(a)

Information Disclosure Statement under 1.97(b)(4)
Attorney Docket No. 020060
Serial No. 10/058,426

concerning the PTO duty to consider and use any such information. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the documents cited in the attached Form PTO-1449 be made of record therein and appear on the first page of any patent to issue therefrom.

The undersigned hereby certifies that each item of information contained in the Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the Information Disclosure Statement.

If there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

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Enclosures: PTO-1449

1 Reference

Chinese Notification of First Office Action



INFORMATION DISCLOSURE CITATION PTO-1449	Atty. Docket No. 020060	Serial No. 10/058,426
	Applicant(s): Daisuke KOMADA et al.	
	Filing Date: January 30, 2002	Group Art Unit: 1756

U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
	AA						
	AB						
	AC						
	AD						
	AE						

FOREIGN PATENT DOCUMENTS

Examiner Initial		Document No.	Date	Country	Translation (Yes or No)
	AF	EP 1 109 221 A2	06/2001	Europe	
	AG				
	AH				
	AI				
	AJ				
	AK				

OTHER DOCUMENTS

	AL	
Examiner		Date Considered